## Notice of References Cited Application/Control No. 10/522,373 Examiner Joseph Lauture Applicant(s)/Patent Under Reexamination HAN ET AL. Page 1 of 1

## **U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification	
*	Α	US-6,825,784	11-2004	Zhang, Weibiao	341/131	
	В	US-				
	С	US-				
	D	US-				
	Ε	US-				
	F	US-				
	G	US-				
	Н	US-				
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	J	US-			·	
	К	US-				
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## FOREIGN PATENT DOCUMENTS

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## **NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)						
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